



	U	1	Document ID	Issue Date	Pages	Title	Current OR
1	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20030144810 A1	20030731	45	Methods and apparatus for data analysis	702/108
2	<input type="checkbox"/>	<input type="checkbox"/>	US 6324298 B1	20011127	33	Automated wafer defect inspection system and a process of performing such inspection	382/149
3	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 6136614 A	20001024	27	Apparatus and method for manufacturing integrated circuit devices	438/5
4	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 5760409 A	19980602	10	Dose control for use in an ion implanter	250/492.21
5	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 4570217 A	19860211	294	Man machine interface	700/83

